updaheer

Freeform Search

US Pre-Grant Publication Full-Text Database US Patents Full-Text Database US OCR Full-Text Database Database: EPO Abstracts Database JPO Abstracts Database **Derwent World Patents Index IBM Technical Disclosure Bulletins** (first focal near array or second focal near Term: array or first FPA or second FPA) 10 Display: Documents in Display Format: |-Starting with Number 1 Generate: O Hit List O Hit Count O Side by Side O Image Clear ... Interrupt Search Search History DATE: Friday, October 26, 2007 **Purge Queries** Printable Copy Create Case Set Name Query side by side DB=PGPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES; OP=ADJ<u>L28</u> (first focal near array or second focal near array or first FPA or second FPA) L27 L22 and (first focal or second focal or first FPA or second FPA) DB=USPT; PLUR=YES; OP=ADJ L26 10554140 DB=PGPB, USPT, USOC, EPAB, JPAB; PLUR=YES; OP=ADJ L25 L17 and (reference near sample or reference near target or reference near object or reference near L24 L22 and (thermal near scan\$4 or temperature near scan\$4 or thermal imag\$3 or temperature imag L23 L22 and (thermal near map\$4 or temperature near map\$4) L17 and (reference near sample or reference near target or reference near object or reference near L21 L17 and (calibrat\$3 near map\$4) L20 L19 and (calibrat\$3 near map\$3) L19 L18 and (calibrat\$3 or reference) L18 L17 and (focal plane array or FPA) <u>L17</u> (374/1,2,120,121,124,129;250/252.1,338.1,339.02,339.03,339.04,339.09,339.11,341.5,393)![CCI DB=USPT; PLUR=YES; OP=ADJ

- =
 - L16 5846276.pn.
 - L15 6331075.pn.
 - L14 5693685.pn.
 - L13 6993926.pn.
 - L12 L10
 - L11 L10
 - L10 6571569.pn.

DB=PGPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES; OP=ADJ

- L9 L8 and L5
- L7 and (flow sensor or flux sensor or flow meter or flux near meter or flow transducer or flux near thermal flux or heat flow path or heat transfer or thermal transfer)
- <u>L7</u> (MEMS or micro near mechanical or nano near mechanical) near5 (manufacturing or producing o DB=PGPB, USPT, USOC, EPAB, JPAB; PLUR=YES; OP=ADJ
- L6 L5 and L3
- $\underline{L5}$ (374/29,43,44,31,137,141,142,143,144,147,10,39,30,100;29/592.1,595;522/1.169,172;427/249.1, [CCLS]

DB=PGPB, USPT, USOC, EPAB, JPAB, DWPI, TDBD; PLUR=YES; OP=ADJ

- <u>L4</u> L3 and (polymer near precursor)
- L2 and (flow sensor or flux sensor or flow meter or flux near meter or flow transducer or flux near thermal flux or heat flow path or heat transfer or thermal transfer)
- L2 (MEMS or micro near mechanical or nano near mechanical) near5 (manufacturing or producing o
- L1 (MEMS or micro near mechanical or nano near mechanical) and (manufacturing or producing or pr

END OF SEARCH HISTORY